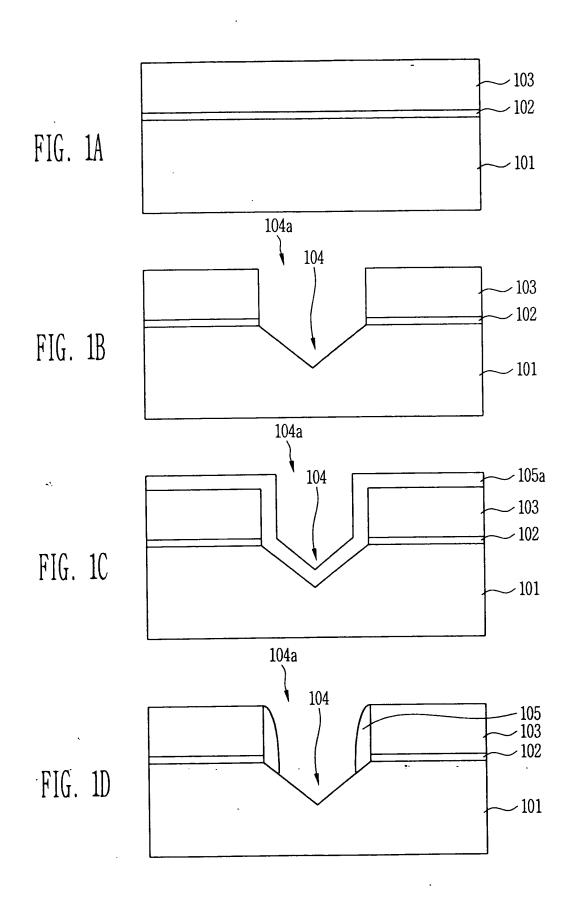
Attorney Docket: 29936/39429
Inventor: Cha Deok Dong

Inventor: Cha Deok Dong
Title: "Method of Forming an Isolation Layer

in a Semiconductor Device"

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Inventor: Cha Deok Dong
Title: "Method of Forming an Isolation
Layer in a Semiconductor Device"

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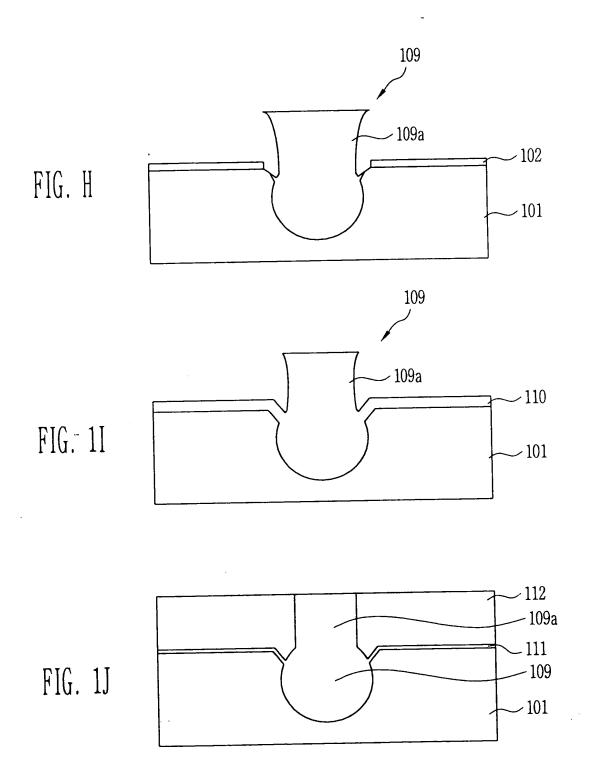
104a 104 - 105 - 103 102 FIG. 1E - 106 √ 101 104a FIG. 1F -107 √101 109 105 ー103 ー102

~101

FIG. 1G

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